

#20/EIN(E)

1/22/03

John H

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Armbrust et al.

Serial No.: 09/666,325

Group Art Unit: 2811

Filed: September 21, 2000

Examiner: Kang, D.

For: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED
ADHESION/ELECTROMIGRATION

Assistant Commissioner of Patents
Washington, D.C. 20231

AMENDMENT UNDER 37 C.F.R. §1.116

Sir:

In response to the Office Action mailed November 18, 2002, please amend the
application as follows.

IN THE CLAIMS:

Please substitute the following claims for the same numbered claims in the application.

